

SPECIFICATION

TITLE OF THE INVENTION

Surface Acoustic Wave Filter and Communication Device Using the Filter

BACKGROUND OF THE INVENTION

Field of the Invention

The present invention relates to a longitudinal-mode surface acoustic wave filter, a method of manufacturing a surface acoustic wave filter, and a communication device.

Related Art of the Invention

In recent years, surface acoustic wave filters have been widely used in mobile communication devices. Surface acoustic wave filters of a longitudinal mode type or a ladder type are used as a filter in a radiofrequency (RF) stage. With the improvement in performance of communication devices such as portable telephones, there has been an increasing demand for reducing the loss and increasing the attenuation in surface acoustic wave filters.

A conventional longitudinal-mode surface acoustic wave filter will be described.

Figure 12 shows a configuration of a conventional longitudinal-mode surface acoustic wave filter. As shown in

Figure 12, the surface acoustic wave filter has a piezoelectric substrate 801, first, second, and third interdigital transducer (IDT) electrodes 802, 803, and 804, and first and second reflector electrodes 805 and 806, the IDT electrodes and the reflector electrodes being formed on the substrate. The upper electrode fingers of each of the second and third IDT electrodes 803 and 804 is connected to an input terminal IN, while the lower electrode fingers of each of the second and third IDT electrodes 803 and 804 is grounded. The lower electrode fingers of the first IDT electrode 802 is connected to an output terminal OUT, while the upper electrode fingers of the first IDT electrode 802 is grounded. The distances between centers of adjacent pairs of the electrode fingers of the first, second, and third IDT electrodes 802, 803, and 804, represented by the distance indicated by P in Figure 12 (hereinafter referred to as "pitch"), are equal to each other. The longitudinal-mode surface acoustic wave filter is thus constructed.

In the above-described surface acoustic wave filter, the electrode fingers are arranged with a constant pitch in order that the acoustic velocity of a surface acoustic wave be constant through the arrangement of the first, second, and third IDT electrodes 802, 803, and 804. In many instances, however, the number of electrode fingers of the first IDT electrode 802 and that of each of the second and third IDT

electrodes 803 and 804 are set different from each other according to a design considering the bandwidth and impedance. Ordinarily, the surface acoustic wave filter is designed so that the number of electrode fingers of the first IDT electrode 802 is larger than that of each of the second and third IDT electrodes 803 and 804.

A longitudinal-mode surface acoustic wave filter has also been used which is designed so that the electrode fingers of each of electrodes have different pitches as shown in Figure 13 to achieve a reduction in loss for example. The conventional longitudinal-mode surface acoustic wave filter shown in Figure 13 is based on a design in which each IDT electrodes have an electrode finger pitch different from that in a main region.

Referring to Figure 13, the surface acoustic wave filter has a piezoelectric substrate 1201, first, second, and third IDT electrodes 1202, 1203, and 1204, and first and second reflector electrodes 1205 and 1206, the IDT electrodes and the reflector electrodes being formed on the substrate. The upper electrode fingers of each of the second and third IDT electrodes 1203 and 1204 is connected to an input terminal IN, while the lower one of each of the second and third IDT electrodes 1203 and 1204 is grounded. The lower electrode fingers of the first IDT electrode 1202 is connected to an output terminal OUT, while the upper electrode fingers of the first IDT electrode 1202 is grounded.

Also, referring to Figure 13, if the pitch in a region indicated by 1a in the first IDT electrode 1202 is P , P is $1/2$ wavelength. If the pitch in a region indicated by 1b is P' , P' is smaller than $1/2$ wavelength. The pitch in a region indicated by 2a in the second IDT electrode 1203 is P , and P is $1/2$ wavelength. The pitch in a region indicated by 2b is P' , and P' is smaller than $1/2$ wavelength. Similarly, the pitch in a region indicated by 3a in the third IDT electrode 1204 is P , and P is $1/2$ wavelength. The pitch in a region indicated by 3b is P' , and P' is smaller than $1/2$ wavelength.

Thus, in each of the first IDT electrode 1202, the second IDT electrode 1203, and the third IDT electrode 1204, different electrode finger pitches are set between the electrode fingers in the same IDT electrodes.

Also in many instances relating to the arrangement shown in Figure 13, the number of electrode fingers of the first IDT electrodes 1202 and that of each of the second and third IDT electrodes 1203 and 1204 are set different from each other according to a design considering the bandwidth and impedance. Ordinarily, the surface acoustic wave filter is designed so that the number of electrode fingers of the first IDT electrode 1202 is larger than that of each of the second and third IDT electrodes 1203 and 1204.

There is a problem in such a surface acoustic wave filter that there is a limit to improvement in filter characteristics in achieving a wide-band characteristic.

SUMMARY OF THE INVENTION

In view of the above-described problem, an object of the present invention is to provide a wide-band surface acoustic wave filter having a steep out-of-band attenuation characteristic, a method of manufacturing the surface acoustic wave filter, and a communication device.

The 1st invention of the present invention is a surface acoustic wave filter comprising:

- a piezoelectric substrate;

- at least an input IDT electrode arranged on said piezoelectric substrate; and

- at least an output IDT electrode arranged on said piezoelectric substrate,

wherein a pitch of electrode fingers of said input IDT electrode and a pitch of electrode fingers of said output IDT electrode are different from each other.

The 2nd invention of the present invention is the surface acoustic wave filter according to 1st invention, wherein the pitch of electrode fingers of the IDT electrode larger in number of electrode fingers in said input and output IDT electrode

is larger than the pitch of electrode fingers smaller in number of electrode fingers.

The 3rd invention of the present invention is a surface acoustic wave filter comprising:

a piezoelectric substrate;

at least an input IDT electrode arranged on said piezoelectric substrate; and

at least an output IDT electrode arranged on said piezoelectric substrate,

wherein the metalization ratio of said input IDT electrodes and the metalization ratio of said output IDT electrodes are different from each other.

The 4th invention of the present invention is the surface acoustic wave filter according to 1st invention, wherein the metalization ratio of an IDT electrode larger in number of electrode fingers in said input and output IDT electrodes is lower than the metalization ratio of an IDT electrode smaller in number of electrode fingers.

The 5th invention of the present invention is the surface acoustic wave filter according to any one of 1st to 4th inventions, wherein if an IDT electrode has a plurality of electrode finger pitches, the pitch of main excitation electrode fingers is set as a basic pitch.

The 6th invention of the present invention is the surface acoustic wave filter according to any one of 1st to 4th

inventions, wherein a peak frequency of a radiation characteristic of said input IDT electrode is substantially equal to a peak frequency of a radiation characteristic of said output IDT electrode.

The 7th invention of the present invention is the surface acoustic wave filter according to 6th invention, wherein one of said input IDT electrode and said output IDT electrode comprises a first IDT electrode including a pair of electrode fingers opposed to each other;

the other of said input IDT electrode and said output IDT electrode comprises a second IDT electrode including a pair of electrode fingers opposed to each other, and a third IDT electrode including a pair of electrode fingers opposed to each other, said second IDT electrode being placed on one side of said first IDT electrode, said third IDT electrode being placed on the other side of said first IDT electrode;

said first, second, and third IDT electrodes are arranged along a direction in which a surface acoustic wave propagates; and

the peak frequency of the radiation characteristic of said first IDT electrode is substantially equal to the peak frequency of the radiation characteristic of each of the second and third IDT electrodes.

The 8th invention of the present invention is the surface acoustic wave filter according to 6th invention, wherein one

of said input IDT electrode and said output IDT electrode comprises first, fourth, and fifth IDT electrodes each including a pair of electrode fingers opposed to each other;

the other of said input IDT electrode and said output IDT electrodes comprises a second and third IDT electrodes each including a pair of electrode fingers opposed to each other;

said second and third IDT electrodes are placed on opposite sides of said first IDT electrode;

said fourth IDT electrode are placed on the side of said second IDT electrodes opposite from the side on which said first IDT electrode are placed;

said fifth IDT electrode are placed on the side of said third IDT electrode opposite from the side on which said first IDT electrode are placed;

said first, second, third, fourth and fifth IDT electrodes are arranged along a direction in which a surface acoustic wave propagates; and

the peak frequencies of the radiation characteristics of at least more than one of the group of said first IDT electrode, and the group of said fourth and fifth IDT electrodes, and the group of said second and third IDT electrodes are substantially equal to each other.

The 9th invention of the present invention is the surface acoustic wave filter according to 6th invention, wherein the

film thickness of said first IDT electrode and the film thickness of each of said second and third IDT electrodes are different from each other.

The 10th invention of the present invention is the surface acoustic wave filter according to 6th invention, wherein the material of said first IDT electrode and the material of each of said second and third IDT electrodes are different from each other.

The 11th invention of the present invention is the surface acoustic wave filter according to 7th invention, wherein the metalization ratio of said first IDT electrode and the metalization ratio of each of said second and third IDT electrodes are equal to each other;

the number of electrode fingers of said first IDT electrode is larger than the number of electrode fingers of each of said second and third IDT electrodes; and

the electrode finger pitch of said first IDT electrode is larger than the electrode finger pitch of each of said second and third IDT electrodes.

The 12th invention of the present invention is the surface acoustic wave filter according to 7th invention, wherein the metalization ratio of said first IDT electrode, the metalization ratio of said second IDT electrode and the metalization ratio of said third IDT electrode are different from each other.

The 13th invention of the present invention is the surface acoustic wave filter according to 7th invention, wherein a plurality of filter tracks each having first, second, and third IDT electrodes, and first and second reflector electrodes are formed on said piezoelectric substrate, and said plurality of filter tracks function as one filter in cooperation with each other.

The 14th invention of the present invention is the surface acoustic wave filter according to 13th invention, wherein each of said plurality of filter tracks is identical in configuration to the others.

The 15th invention of the present invention is the surface acoustic wave filter according to 13th invention, wherein at least one of said plurality of filter tracks is different in configuration from the others.

The 16th invention of the present invention is the surface acoustic wave filter according to 7th invention, further comprising a first reflector electrode placed on the opposite side of said second IDT electrode on said piezoelectric substrate opposite from the side on which said first IDT electrode are placed; and

a second reflector electrode placed on the side of said third IDT electrode on said piezoelectric substrate opposite from the side on which said first IDT electrode are placed,

wherein said first, second, and third IDT electrodes and said first and second reflector electrodes are arranged along a direction in which a surface acoustic wave propagates.

The 17th invention of the present invention is a method of manufacturing a surface acoustic wave filter, comprising

a piezoelectric substrate;

an input IDT electrode arranged on the piezoelectric substrate; and

an output IDT electrode arranged on the piezoelectric substrate,

wherein said method makes a pitch of electrode fingers of said input IDT electrode and a pitch of electrode fingers of said output IDT electrode different values.

The 18th invention of the present invention is a communication device comprising:

a transmitting circuit which outputs a transmitted wave; and

a receiving circuit to which a wave to be received is input,

wherein a surface acoustic wave filter according to 1st invention is used in said transmitting circuit and/or in said receiving circuit.

The 19th invention of the present invention is a communication device comprising:

a transmitting circuit which outputs a transmitted wave;
and

a receiving circuit to which a wave to be received is
input,

wherein the surface acoustic wave filter according to
3rd invention is used in said transmitting circuit and/or in
said receiving circuit.

BRIEF DESCRIPTION OF THE DRAWINGS

Figure 1 is a diagram of a configuration of a surface
acoustic wave filter in a first embodiment of the present
invention.

Figure 2 is a diagram showing a relationship between
(peak frequencies) of radiation characteristics and the number
of electrode fingers.

Figure 3 is a diagram of a configuration of a surface
acoustic wave filter in a second embodiment of the present
invention.

Figure 4 is a graph of radiation characteristics of IDT
electrodes in the first and third embodiments of the present
invention.

Figure 5 is a graph of a path characteristic of the surface
acoustic wave filter in the first and third embodiments of
the present invention.

Figure 6 is a diagram of a configuration of a surface acoustic wave filter in a third embodiment of the present invention.

Figure 7 is a diagram of a configuration of a surface acoustic wave filter in a fourth embodiment of the present invention.

Figure 8(a) is a graph of radiation characteristics of IDT electrodes in the second embodiment of the present invention.

Figure 8(b) is a graph of a pass characteristic of the surface acoustic wave filter in the second embodiment of the present invention.

Figure 9(a) is a graph of radiation characteristics of IDT electrodes in a conventional surface acoustic wave filter in which peak frequencies of radiation characteristic of IDT electrodes do not coincide with each other.

Figure 9(b) is a graph of a pass characteristic of the surface acoustic wave filter relating to Figure 9(a).

Figure 10 is a diagram of a configuration of a surface acoustic wave filter in a fifth embodiment of the present invention.

Figure 11 is a diagram of a configuration of a surface acoustic wave filter in a sixth embodiment of the present invention.

Figure 12 is a diagram of a configuration of a conventional surface acoustic wave filter.

Figure 13 is a diagram of a configuration of another conventional surface acoustic wave filter.

Description of Symbols

- 101 piezoelectric substrate
- 102 first IDT electrodes
- 103 second IDT electrodes
- 104 third IDT electrodes
- 105 reflector electrode
- 106 reflector electrode
- 301 piezoelectric substrate
- 302 first IDT electrodes
- 303 second IDT electrodes
- 304 third IDT electrodes
- 305 reflector electrode
- 306 reflector electrode
- 307 filter track
- 308 fourth IDT electrodes
- 309 fifth IDT electrodes
- 310 sixth IDT electrodes
- 311 reflector electrode
- 312 reflector electrode
- 313 filter track

601 piezoelectric substrate
602 first IDT electrodes
603 second IDT electrodes
604 third IDT electrodes
605 reflector electrode
606 reflector electrode
701 piezoelectric substrate
702 first IDT electrodes
703 second IDT electrodes
704 third IDT electrodes
705 reflector electrode
706 reflector electrode
707 filter track
708 fourth IDT electrodes
709 fifth IDT electrodes
710 sixth IDT electrodes
711 reflector electrode
712 reflector electrode
713 filter track

PREFERRED EMBODIMENTS OF THE INVENTION

Embodiments of the present invention will be described with reference to the drawings.

(First Embodiment)

A first embodiment of the present invention will be described. Figure 1 schematically shows a surface acoustic

wave filter which represents a first embodiment of the present invention.

Referring to Figure 1, the surface acoustic wave filter has a piezoelectric substrate 101, first, second, and third IDT electrodes 102, 103, and 104, and first and second reflector electrodes 105 and 106, the IDT electrodes and the reflector electrodes being formed on the substrate.

The second IDT electrode 103 and the third IDT electrode 104 are placed on the opposite sides of the first IDT electrode 102. The reflector electrode 105 is placed on the side of the second IDT electrode 103 opposite from the side on which the first IDT electrode 102 are placed. The reflector electrode 106 is placed on the side of the third IDT electrode 104 opposite from the side on which the first IDT electrode 102 are placed. Thus, the first, second, and third IDT electrode 102, 103, and 104 and the first and second reflector electrodes 105 and 106 are arranged along the direction of propagation of a surface acoustic wave.

The upper electrode fingers of each of the second and third IDT electrodes 103 and 104 is connected to an input terminal IN, while the lower electrode fingers of each of the second and third IDT electrodes 103 and 104 is grounded. The lower electrode fingers of the first IDT electrode 102 is connected to an output terminal OUT, while the upper electrode fingers of the first IDT electrode 102 is grounded.

The number of electrode fingers of the first IDT electrode 102 is larger than that of each of the second and third IDT electrodes 103 and 104, and the number of electrode fingers of the second IDT electrode 103 and that of the third IDT electrode 104 are equal to each other.

If the pitch of the first IDT electrode 102 is represented by P_1 and the pitch of the second and third IDT electrode 103 and 104 is represented by P_2 , the relationship between P_1 and P_2 is $P_1 > P_2$.

The first IDT electrode 102 and each of the second and third IDT electrode 103 and 104 have metalization ratios η equal to each other. The metalization ratio η represents the proportion of the width of the electrode finger in one wavelength.

The metalization ratio η is expressed by the following equation (1).

[Equation 1]

$$\eta = L / (L + S)$$

where L is the width of one electrode finger and S is the spacing from this electrode finger to the next electrode finger.

The operation of this embodiment will now be described.

Figure 2 shows the relationship between the number and the metalization ratio η of electrode fingers of the first IDT electrode 102 and peak frequencies of radiation characteristics of the first IDT electrode 102. A peak

frequency of a radiation characteristic is defined as a frequency at which level of the radiation is peaked. That is, the radiation characteristic of the first IDT electrode 102 is measured with respect to particular values of the number and the metalization ratio η of electrode fingers of the first IDT electrode 102 when the pitch is fixed to obtain the peak frequency of the radiation characteristic, and the characteristics curves shown in Figure 2 are formed by plotting the center frequencies obtained.

As described above, while the number of electrode fingers and the metalization ratio η of the first IDT electrode 102 are changed in the process of obtaining the relationship shown in Figure 2, the electrode finger pitch is fixed.

As is apparent from Figure 2, when the number of electrode fingers of the first IDT electrode 102 is more increased, the peak frequency of the radiation characteristic of the first IDT electrode 102 is higher. Also, if the metalization ratio η of the first IDT electrode 102 is increased, the center frequency of the radiation characteristic of the first IDT electrode 102 is lower. Thus, the peak frequency of the radiation characteristic of the first IDT electrode 102 becomes higher when the number of electrode fingers is more increased or when the metalization ratio η is more reduced while the electrode film thickness of the first IDT electrode 102 is constant. With respect to the second and third IDT electrodes

103 and 104, the same tendency as that observed with respect to the first IDT electrode 102 is recognized.

In Figure 4, the radiation characteristic of the first IDT electrode 102 is indicated by 401. As clearly shown in Figure 4, the radiation characteristic of the first IDT electrode 102 is asymmetric about the center frequency because of the influence of a reflection characteristic.

The radiation characteristic of the second IDT electrode 103 is indicated by 402 in Figure 4. The radiation characteristic of the second IDT electrode 103 is asymmetric about the center frequency because of the influence of a reflection characteristic, as is that of the first IDT electrode 102. Since the third IDT electrode 104 has the same number of electrode fingers as the second IDT electrode 103, the radiation characteristic of the third IDT electrode 104 is the same as that of the second IDT electrode 103. Therefore the radiation characteristic of the third IDT electrode 104, as well as that of the second IDT electrode 103, is indicated by 402 in Figure 4.

On the other hand, the inventor of the present invention found the fact that the surface acoustic wave filter has an improved characteristic if it is designed so that the center frequency of the radiation characteristic 401 of the first IDT electrode 102 and the center frequency of the radiation characteristic 402 of the second and third IDT electrodes 103

and 104 are equal to each other, i.e., the fact that if the surface acoustic wave filter is designed in this manner, it has an attenuation characteristic of a wider band.

As mentioned above, the number of electrode fingers of the first IDT electrode 102 is larger than that of each of the second and third IDT electrodes 103 and 104. Therefore, as is apparent from Figure 2, if the pitch of the electrode fingers of the first IDT electrode 102 is equal to that of the electrode fingers of each of the second and third IDT electrodes 103 and 104, the center frequency of the radiation characteristic of the first IDT electrode 102 is higher than that of the radiation characteristic of the second and third IDT electrodes 103 and 104.

However, as is apparent from Figure 2, the center frequency of the radiation characteristic of the first IDT electrode 102 and that of the radiation characteristic of the second and third IDT electrodes 103 and 104 can be set approximately equal to each other by establishing the relationship $P_1 > P_2$. More specifically, while there is a difference of about 0.9% between the center frequencies of the radiation characteristics when $P_1 = P_2$, the difference between the center frequencies of the radiation characteristics can be reduced to about 0.5% and, preferably, to 0.1% by establishing the relationship $P_1 > P_2$. That is, the pitch of the group of electrode fingers larger in number in the groups of electrode

fingers of the IDT electrodes constituting the surface acoustic wave filter shown in Figure 1 may be adjusted so as to be larger than the pitch of the other groups of electrode fingers smaller in number to set the radiation characteristics of the IDT electrodes in correspondence with each other.

The surface acoustic wave filter is thus arranged to be realized as a wide-band filter having a steep attenuation characteristic.

While this embodiment has been described by assuming that the input terminal IN is of an unbalanced type, the input terminal IN is not limited to the unbalanced type. A balanced type of input terminal IN may alternatively be used.

While this embodiment has been described by assuming that the output terminal OUT is an unbalanced type, the output terminal OUT is not limited to the unbalanced type. A balanced type of output terminal OUT may alternatively be used.

This embodiment has been described with respect to the case where each electrodes in the second and third IDT electrodes 103 and 104 is connected to the input terminal IN while the first IDT electrode 102 is connected to the output terminal OUT. However, the arrangement may alternatively be such that each electrodes in the second and third IDT electrodes 103 and 104 is connected to the output terminal OUT while the first IDT electrode 102 is connected to the input terminal IN.

This embodiment has been described by assuming that the number of fingers of the second and third IDT electrodes are equal to each other. However, if these numbers are different, the IDT electrodes may be adjusted so that their radiation characteristics coincide with each other.

(Second Embodiment)

A second embodiment of the present invention will be described.

Figure 3 schematically shows a surface acoustic wave filter of this embodiment.

Referring to Figure 3, a first filter track 307 is formed on a piezoelectric substrate 301 by first, second, and third IDT electrodes 302, 303, and 304, and first and second reflector electrodes 305 and 306. That is, the second IDT electrodes 303 and the third IDT electrodes 304 are placed on the both sides of the first IDT electrodes 302. The reflector electrode 305 is placed on the side of the second IDT electrode 303 opposite from the side on which the first IDT electrode 302 are placed. The reflector electrode 306 is placed on the side of the third IDT electrode 304 opposite from the side on which the first IDT electrode 302 are placed.

Also, a second filter track 313 is formed by fourth, fifth, and sixth IDT electrodes 308, 309, and 310, and first and second reflector electrodes 311 and 312. That is, the fifth IDT electrode 309 and the sixth IDT electrode 310 are placed on

the opposite sides of the fourth IDT electrode 308. The reflector electrode 311 is placed on the side of the fifth IDT electrode 309 opposite from the side on which the fourth IDT electrode 308 are placed. The reflector electrode 312 is placed on the side of the sixth IDT electrode 310 opposite from the side on which the fourth IDT electrode 308 are placed.

The upper electrode fingers of the first IDT electrode 302 is connected to an input terminal IN. The lower electrode fingers of the second IDT electrode 303 is connected to the upper electrode fingers of the fifth IDT electrode 309, and the lower electrode fingers of the third IDT electrode 304 is connected to the upper electrode fingers of the sixth IDT electrode 310. The upper electrode fingers of the fourth IDT electrode 308 is connected to an output terminal OUT1, while the lower electrode fingers of the fourth IDT electrode 308 is connected to another output terminal OUT2.

The number of electrode fingers of the first IDT electrode 302 is equal to that of the fourth IDT electrode 308. The second IDT electrode 303, the third IDT electrode 304, the fifth IDT electrode 309 and the sixth IDT electrode 310 have numbers of electrode fingers equal to each other.

The number of electrode fingers of each of the first and fourth IDT electrodes 302 and 308 is larger than that of each of the second, third, fifth, and sixth IDT electrodes 303, 304, 309, and 310. The pitch of the electrode fingers of the

first and fourth IDT electrodes 302 and 308 is represented by $P1$ and the pitch of the electrode fingers of the second, third, fifth, and sixth IDT electrodes 303, 304, 309, and 310 is represented by $P2$. The relationship between $P1$ and $P2$ is $P1 > P2$. The metalization ratios of all of IDT electrodes are equal to each other. The surface acoustic wave filter of this embodiment is thus constructed as a two-stage longitudinal-mode surface acoustic wave filter.

The operation of this embodiment will be described.

Figure 8(a) shows radiation characteristics of the first and second IDT electrodes 302 and 303. The radiation characteristic of the first IDT electrode 302 is indicated by 1801 and the radiation characteristic of the second IDT electrode 303 is indicated by 1802. As is apparent from Figure 8, the peak frequency of the radiation characteristic 1801 and the peak frequency of the radiation characteristic 1802 coincide with each other. The peak frequencies f_p of the radiation characteristics of the first and second IDT electrodes 302 and 303 can be set approximately equal to each other by establishing the relationship $P1 > P2$, as in the first embodiment. Also, the peak frequency f_p of the radiation characteristic of the first IDT electrode 302 can be set approximately equal to the peak frequency f_p of the radiation characteristic of the third IDT electrode 304 by establishing the relationship $P1 > P2$. Further, the peak frequency f_p of

the radiation characteristic of the fourth IDT electrode 308 can be set approximately equal to the peak frequency f_p of the radiation characteristic of each of the fifth and sixth IDT electrodes 309 and 310 by establishing the relationship $P_1 > P_2$.

Figure 8(b) shows a pass characteristic of the surface acoustic wave filter of this embodiment indicated by 1803a and by 1803b. The pass characteristic of the surface acoustic wave filter of this embodiment is indicated by 1803a with respect to a wide gain range from 0 dB to 90 dB, and a central portion of the characteristic curve 1803a is indicated by 1803b with respect to a narrow gain range from 0 dB to 10 dB. Frequency f_p is the peak frequency of the radiation characteristic of each IDT electrodes. This filter pass characteristic of the surface acoustic wave filter is exhibited when the peak frequency f_p of the radiation characteristic of each IDT electrodes is set in correspondence with the left end of the pass band, i.e., the lower limit frequency of the pass band.

Figure 9(a) shows radiation characteristics of IDT electrodes in a conventional surface acoustic wave filter. In Figure 9(a), the first and fourth IDT electrodes 302 and 308 have the radiation characteristic indicated by 1901, and the second, third, fifth, and sixth IDT electrodes 303, 304, 309, and 310 have the radiation characteristic indicated by 1902. That is, in the conventional surface acoustic wave

filter, the center frequency fp_1 of the first and fourth IDT electrodes 302 and 308 and the center frequency fp_2 of the second, third, fifth, and sixth IDT electrodes 303, 304, 309, and 310 do not coincide with each other.

Figure 9(b) shows a pass characteristic of this surface acoustic wave filter indicated by 1903a and by 1903b. The pass characteristic of the conventional surface acoustic wave filter is indicated by 1903a with respect to a wide gain range from 0 dB to 90 dB, and a central portion of the characteristic curve 1903a is indicated by 1903b with respect to a narrow gain range from 0 dB to 10 dB.

In the pass characteristic 1803b shown in Figure 8(b), an improvement is recognized in comparison with the pass characteristic 1903b shown in Figure 9(b), such that a cut of the pass band at the left end is reduced to widen the pass band. This means a reduction in loss at the band end.

Thus, the center frequencies of the radiation characteristics of the IDT electrodes are set approximately equal to each other to realize a surface acoustic wave filter having a characteristic of a wider band.

As described above, according to this embodiment, a wide-band surface acoustic wave filter having a steep attenuation characteristic can be realized.

While the output terminals form a balanced output in this embodiment, the same effect of the present invention can also

be achieved even if the upper or lower one of the fourth IDT electrode may be grounded to form an unbalanced output.

(Third Embodiment)

A third embodiment of the present invention will be described.

Figure 6 schematically shows a surface acoustic wave filter of this embodiment. Referring to Figure 6, the surface acoustic wave filter has a piezoelectric substrate 601, first, second, and third IDT electrodes 602, 603, and 604, and first and second reflector electrodes 605 and 606, the IDT electrodes and the reflector electrodes being formed on the substrate.

The second IDT electrode 603 and the third IDT electrode 604 are placed on the both sides of the first IDT electrode 602. The reflector electrode 605 is placed on the side of the second IDT electrode 603 opposite from the side on which the first IDT electrode 602 are placed. The reflector electrode 606 is placed on the side of the third IDT electrode 604 opposite from the side on which the first IDT electrode 602 are placed.

The upper electrode fingers of each of the second and third IDT electrodes 603 and 604 is connected to an input terminal IN, while the lower electrode fingers of each of the second and third IDT electrodes 603 and 604 is grounded. The lower electrode of the first IDT electrode 602 is connected

to an output terminal OUT, while the upper one of the first IDT electrode 602 is grounded.

The number of electrode fingers of the first IDT electrode 602 is larger than that of each of the second and third IDT electrodes 603 and 604, and the number of electrode fingers of the second IDT electrode 603 and that of the third IDT electrode 604 are equal to each other.

The pitch of the electrode fingers of the first IDT electrode 602 is represented by P_1 and the pitch of the electrode fingers of the second and third IDT electrodes 603 and 604 is represented by P_2 . The relationship between P_1 and P_2 is $P_1 > P_2$.

In the surface acoustic wave filter of this embodiment, the first IDT electrode 602 and each of the second and third IDT electrodes 603 and 604 have metalization ratios different from each other.

The operation of this embodiment will be described.

The number of electrode fingers of the first IDT electrode 602 is larger than that of each of the second and third IDT electrodes 603 and 604. Therefore, as is apparent from Figure 2, if the metalization ratio of the first IDT electrode 602 is equal to that of the second and third IDT electrodes 603 and 604, the center frequency of the radiation characteristic of the first IDT electrode 602 is higher than that of the

radiation characteristic of the second and third IDT electrodes 603 and 604.

However, as is apparent from Figure 2, the peak frequency of the radiation characteristic of the first IDT electrode 602 and that of the radiation characteristic of the second and third IDT electrodes 603 and 604 can be set approximately equal to each other by establishing the relationship $P1 > P2$ and by making the metalization ratio of the first IDT electrode 602 and the metalization ratio of the second and third IDT electrodes 603 and 604 different values.

In this embodiment, as described above, the center frequency of the radiation characteristic of the first IDT electrode 602 and the center frequency of the radiation characteristic of the second and third IDT electrodes 603 and 604 can be set approximately equal to each other by adjusting the pitch and the metalization ratio of each IDT electrodes. Since adjustment of the metalization of each IDT electrode, i.e., adjustment of the intensity of surface acoustic wave excitation and the reflection on each IDT electrodes, is also performed, the design freedom is improved in comparison with the first embodiment.

While in this embodiment the pitches are adjusted so that $P1 > P2$, being not exclusively used adjustment of the metalization ratio may alternatively be performed while the pitches are set in the relationship $P1 = P2$.

The surface acoustic wave filter is thus arranged to be realized as a wide-band filter having a steep attenuation characteristic.

While this embodiment has been described by assuming that the input terminal IN is of an unbalanced type, the input terminal IN is not limited to the unbalanced type. A balanced type of input terminal IN may alternatively be used.

While this embodiment has been described by assuming that the output terminal OUT is an unbalanced type, the output terminal OUT is not limited to the unbalanced type. A balanced type of output terminal OUT may alternatively be used.

This embodiment has been described with respect to the case where the second and third IDT electrodes 603 and 604 is connected to the input terminal IN while the first IDT electrode 602 is connected to the output terminal OUT. However, the arrangement may alternatively be such that the second and third IDT electrodes 603 and 604 is connected to the output terminal OUT while the first IDT electrode 602 is connected to the input terminal IN.

(Fourth Embodiment)

A fourth embodiment of the present invention will be described.

Figure 7 schematically shows a surface acoustic wave filter of this embodiment.

Referring to Figure 7, a first filter track 707 is formed on a piezoelectric substrate 701 by first, second, and third IDT electrodes 702, 703, and 704 and first and second reflector electrodes 705 and 706. That is, the second IDT electrode 703 and the third IDT electrode 704 are placed on the both sides of the first IDT electrode 702. The reflector electrode 705 is placed on the side of the second IDT electrode 703 opposite from the side on which the first IDT electrode 702 are placed. The reflector electrode 706 is placed on the side of the third IDT electrode 704 opposite from the side on which the first IDT electrode 702 are placed.

Also, a second filter track 713 is formed by fourth, fifth, and sixth IDT electrodes 708, 709, and 710, and first and second reflector electrodes 711 and 712. That is, the fifth IDT electrode 709 and the sixth IDT electrode 710 are placed on the both sides of the fourth of IDT electrode 708. The reflector electrode 711 is placed on the side of the fifth IDT electrode 709 opposite from the side on which the fourth IDT electrode 708 are placed. The reflector electrode 712 is placed on the side of the sixth IDT electrode 710 opposite from the side on which the fourth IDT electrode 708 are placed.

The upper electrode fingers of the first IDT electrodes 702 is connected to an input terminal IN. The lower electrode fingers of the IDT electrode 703 is connected to the upper electrode fingers of the fifth IDT electrode 709, and the lower

electrode fingers of the third IDT electrode 704 is connected to the upper electrode fingers of the sixth IDT electrode 710. The upper electrode fingers of the fourth IDT electrode 708 is connected to an output terminal OUT1, while the lower electrode fingers of the fourth IDT electrode 708 is connected to another output terminal OUT2.

The number of electrode fingers of the first IDT electrode 702 is equal to that of the fourth IDT electrode 708. The second IDT electrode 703, the third IDT electrode 704, the fifth IDT electrode 709 and the sixth IDT electrode 710 have numbers of electrode fingers equal to each other.

The number of electrode fingers of each of the first and fourth IDT electrodes 702 and 708 is larger than that of each of the second, third, fifth, and sixth IDT electrodes 703, 704, 709, and 710. The pitch of the electrode fingers of the first IDT electrode 702 is represented by P_{11} and the pitch of the electrode fingers of the second and third IDT electrodes 703 and 704 is indicated by P_{12} . The relationship between P_{11} and P_{12} is $P_{11} > P_{12}$. Also, the pitch of the electrode fingers of the fourth IDT electrode 708 is represented by P_{21} and the pitch of the electrode fingers of the fifth and sixth IDT electrodes 709 and 710 is indicated by P_{22} . The relationship between P_{21} and P_{22} is $P_{21} > P_{22}$.

The metalization ratio η_{11} of the first IDT electrode 702 in the first filter track 707 is expressed by the following equation (2):

[Equation 2]

$$\eta_{11} = L_{11} / (L_{11} + S_{11})$$

where L_{11} is the width of the electrode fingers of the first IDT electrode 702, and S_{11} is the spacing from one electrode finger to the next electrode finger in the first IDT electrodes 702.

The metalization ratio η_{12} of the second and third IDT electrodes 703 and 704 is expressed by the following equation (3):

[Equation 3]

$$\eta_{12} = L_{12} / (L_{12} + S_{12})$$

where L_{12} is the width of the electrode fingers of the second and third IDT electrodes 703 and 704, and S_{12} is the spacing from one electrode finger to the next electrode finger in the second and third IDT electrodes 703 and 704.

The metalization ratio η_{21} of the fourth IDT electrode 708 in the second filter track 708 is expressed by the following equation (4):

[Equation 4]

$$\eta_{21} = L_{21} / (L_{21} + S_{21})$$

where L_{21} is the width of the electrode fingers of the fourth IDT electrode 708, and S_{21} is the spacing from one electrode

finger to the next electrode finger in the fourth IDT electrode 708.

The metalization ratio η_{22} of the fifth and sixth IDT electrodes 709 and 710 is expressed by the following equation (5) :

[Equation 5]

$$\eta_{22} = L_{22} / (L_{22} + S_{22})$$

where L_{22} is the width of the electrode fingers of the fifth and sixth IDT electrodes 709 and 710, and S_{22} is the spacing from one electrode finger to the next electrode finger in the fifth and sixth IDT electrodes 709 and 710.

In this embodiment, η_{11} and η_{12} shown above are different from each other, and η_{21} and η_{22} shown above are also different from each other.

The surface acoustic wave filter of this embodiment is thus constructed as a two-stage longitudinal-mode surface acoustic wave filter.

The operation of this embodiment will be described.

The center frequency f_p of the radiation characteristic of the first IDT electrode 702 and the center frequency f_p of the radiation characteristic of the second and third IDT electrodes 703 and 704 are set approximately equal to each other by establishing the relationship $P_{11} > P_{12}$ and by adjusting η_{11} and η_{12} to different values in accordance with

the same method as that described above in detail in the description of the embodiments.

Also, the peak frequency f_p of the radiation characteristic of the fourth IDT electrode 708 and the peak frequency f_p of the radiation characteristic of the fifth and sixth IDT electrodes 709 and 710 are set approximately equal to each other by establishing the relationship $P_{21} > P_{22}$ and by adjusting η_{21} and η_{22} to different values.

Consequently, the surface acoustic wave filter of this embodiment can be realized as a wide-band surface acoustic wave filter having a steep attenuation characteristic, as are those in the above-described embodiments.

A wide-band surface acoustic wave filter having a steep attenuation characteristic can be realized by being arranged as described above.

This embodiment has been described with respect to the case where η_{11} and η_{12} are adjusted to different values while the relationship $P_{11} > P_{12}$ is established, and where η_{21} and η_{22} are adjusted to different values while the relationship $P_{21} > P_{22}$ is established. However, this adjustment method is not exclusively used. Adjustment using only the relationship $P_{11} > P_{21}$ and the relationship $P_{21} > P_{22}$ may alternatively be performed. Also, adjustment by changing only the metalization ratio while establishing $P_{11} = P_{12}$ and $P_{21} = P_{22}$ may be performed.

While the output terminals form a balanced output in this embodiment, the same effect of the present invention can also be achieved even if the upper or lower one of the fourth IDT electrode 708 may be grounded to form an unbalanced output.

(Fifth Embodiment)

A fifth embodiment of the present invention will be described.

Figure 10 schematically shows a surface acoustic wave filter of this embodiment.

Referring to Figure 10, the surface acoustic wave filter has a piezoelectric substrate 1001, first, second, and third IDT electrodes 1002, 1003, and 1004, and first and second reflector electrodes 1005 and 1006, the IDT electrodes and the reflector electrodes being formed on the substrate.

The second IDT electrode 1003 and the third IDT electrodes 1004 are placed on the opposite sides of the first IDT electrode 1002. The reflector electrode 1005 is placed on the side of the second IDT electrode 1003 opposite from the side on which the first IDT electrode 1002 are placed. The reflector electrode 1006 is placed on the side of the third IDT electrodes 1004 opposite from the side on which the first IDT electrode 1002 are placed. Thus, the first, second, and third IDT electrodes 1002, 1003, and 1004 and the first and second reflector electrodes 1005 and 1006 are arranged along the direction of propagation of a surface acoustic wave.

The upper electrode fingers of each of the second and third IDT electrodes 1003 and 1004 is connected to an input terminal IN, while the lower electrode fingers of each of the second and third IDT electrodes 1003 and 1004 is grounded. The lower electrode fingers of the first IDT electrode 1002 is connected to an output terminal OUT, while the upper electrode fingers of the first IDT electrode 1002 is grounded.

The number of electrode fingers of the first IDT electrode 1002 is larger than that of each of the second and third IDT electrodes 1003 and 1004, and the number of electrode fingers of the second IDT electrode 1003 and that of the third IDT electrode 1004 are equal to each other.

If the pitch in a region indicated by 1a in the first IDT electrode 1002 is P_1 , P_1 is $1/2$ wavelength. Also, if the pitch in a region indicated by 1b is P_1' , P_1' is smaller than $1/2$ wavelength. The number of electrode fingers in the region 1a having the pitch P is larger than the number of electrode fingers in the region 1b having the pitch P_1' . In the first IDT electrode 1002, therefore, the region indicated by 1a is a main excitation region.

Also, if the pitch in a region indicated by 2a in the second IDT electrode 1003 is P_2 , P_2 is $1/2$ wavelength. Also, if the pitch in a region indicated by 2b is P_2' , P_2' is smaller than $1/2$ wavelength. The number of electrode fingers in the region 2a having the pitch P_2 is larger than the number of

electrode fingers in the region 2b having the pitch $P2'$. In the second IDT electrode 1003, therefore, the region indicated by 2a is a main excitation region.

The pitch in a region indicated by 3a in the third IDT electrode 1004 is $P2$, and $P2$ is $1/2$ wavelength. The pitch in a region indicated by 3b is $P2'$, and $P2'$ is smaller than $1/2$ wavelength. The number of electrode fingers in the region 3a having the pitch $P2$ is larger than the number of electrode fingers in the region 3b having the pitch $P2'$. In the third IDT electrode 1004, therefore, the region indicated by 3a is a main excitation region.

Thus, in each of the first IDT electrode 1002, the second IDT electrode 1003 and the third IDT electrode 1004, different electrode finger pitches are set between the electrode fingers of the same IDT electrode.

If the relationship between the pitch $P1$ and $P2$ satisfies $P1 > P2$, the same effect as that of the first embodiment can be achieved.

In the case where the relationship between the pitch $P1$ and $P2$ satisfies $P1 > P2$, the relationship between the pitch $P1'$ and $P2'$ may satisfy $P1' > P2'$ or $P1' = P2'$. The discontinuity between the adjacent electrode fingers when $P1' > P2'$ is satisfied can be smaller than that when $P1' = P2'$ is satisfied. The insertion loss can be relatively reduced by satisfying $P1' > P2'$.

While this embodiment has been described with respect to the case where $P_1 > P_2$ is satisfied, the P_1 and P_2 may be adjusted so that the respective peak frequencies of radiation characteristics of the regions 1a, 2a, and 3a shown in Figure 10 are set approximately equal to each other. It is desirable that the pitch P_1 , P_1' , P_2 , and P_2' be adjusted so that the radiation characteristics of the first, second, and third IDT electrodes 1002, 1003, and 1004 coincide with each other. In such a case, equality between the pitches p_2 and P_2' of the second and third IDT electrodes 1003 and 1004 is not necessarily required.

To an arrangement in which the electrode fingers of one IDT electrode have different pitches as described above, each of the above-described embodiments may be applied on the basis of a setting of the pitches of the main excitation electrode fingers in the main excitation regions.

A wide-band surface acoustic wave filter having a steep attenuation characteristic can be realized by being arranged as described above.

While this embodiment has been described by assuming that the input terminal IN is of an unbalanced type, the input terminal IN is not limited to the unbalanced type. A balanced type of input terminal IN may alternatively be used.

While this embodiment has been described by assuming that the output terminal OUT is an unbalanced type, the output

terminal OUT is not limited to the unbalanced type. A balanced type of output terminal OUT may alternatively be used.

This embodiment has been described with respect to the case where the second and third IDT electrodes 1003 and 1004 is connected to the input terminal IN while the first IDT electrode 1002 is connected to the output terminal OUT. However, the arrangement may alternatively be such the second and third IDT electrodes 1003 and 1004 is connected to the output terminal OUT while the first IDT electrode 1002 is connected to the input terminal IN.

(Sixth Embodiment)

A sixth embodiment of the present invention will be described.

Figure 11 schematically shows a surface acoustic wave filter of this embodiment.

Referring to Figure 11, the surface acoustic wave filter has a piezoelectric substrate 101, first, second, third, fourth, and fifth IDT electrodes 1102, 1103, 1104, 1105, and 1106, and first and second reflector electrodes 1107 and 1108, the IDT electrodes and the reflector electrodes being formed on the substrate.

The second IDT electrode 1103 and the third IDT electrode 1104 are placed on the both sides of the first IDT electrode 1102. The fifth IDT electrode 1106 are placed on the side of the third IDT electrode 1104 opposite from the side on which

the first IDT electrode 1102 are placed. The fourth IDT electrode 1105 are placed on the side of the second IDT electrode 1103 opposite from the side on which the first IDT electrode 1102 are placed. The first reflector electrode 1107 is placed outside the fourth IDT electrode 1105, and the second reflector electrode 1108 is placed outside the fifth IDT electrode 1106.

Thus, the first, second, third, fourth, and fifth IDT electrodes 1102, 1103, 1104, 1105, and 1106 and the first and second reflector electrodes 1107 and 1108 are arranged along the direction of propagation of a surface acoustic wave.

The lower electrode fingers of each of the second and third IDT electrodes 1103 and 1104 is connected to an output terminal OUT, while the upper electrode fingers of each of the second and third IDT electrodes 1103 and 1104 is grounded. The upper electrode fingers of each of the first, fourth, and fifth IDT electrodes 1102, 1105, and 1106 is connected to an input terminal IN, while the lower electrode fingers of each of the first, fourth, and fifth IDT electrodes 1102, 1105, and 1106 is grounded.

The number of electrode fingers of the first IDT electrode 1102 is larger than that of each of the second and third IDT electrodes 1103 and 1104, and the number of electrode fingers of the second IDT electrode 1103 and that of the third IDT electrode 1104 are equal to each other. Also, the number of electrode fingers of each of the fourth and fifth IDT electrodes

1105 and 1106 is smaller than that of each of the second and third IDT electrodes 1103 and 1104, and the number of electrode fingers of the fourth IDT electrode 1105 and that of the fifth IDT electrode 1106 are equal to each other.

If the pitch of the electrode fingers of the first of IDT electrode 1102 is P_1 ; the pitch of the electrode fingers of the second and third IDT electrodes 1103 and 1104 is P_2 ; and the pitch of the electrode fingers of the fourth and fifth IDT electrodes 1105 and 1106 is P_3 , the pitches P_1 to P_3 are in the relationship $P_1 > P_2 > P_3$. That is, the pitch of one group of electrode fingers larger in number in the groups of electrode fingers of the IDT electrodes constituting the surface acoustic wave filter of this embodiment is larger than the pitch of another group of electrode fingers smaller in number.

The first, second, third, fourth, and fifth IDT electrodes 1102, 1103, 1104, 1105, and 1106 have metalization ratios η equal to each other. The metalization ratio η represents the proportion of the width of the electrode finger in one wavelength.

The metalization ratio η is expressed by the equation (1) shown above in the description of the first embodiment.

The operation of this embodiment will be described.

If the number of electrode fingers of the first IDT electrode 1102 is increased, the center frequency of the

radiation characteristic of the first IDT electrode 1102 is higher, as described above in the description of the first embodiment. Also, if the metalization ratio η of the first IDT electrode 1102 is increased, the center frequency of the radiation characteristic of the first IDT electrode 1102 is lower. Thus, the center frequency of the radiation characteristic of the first IDT electrode 1102 becomes higher if the number of electrode fingers is increased or if the metalization ratio η is reduced while the electrode film thickness of the first IDT electrode 1102 is constant. With respect to the second, third, fourth, and fifth IDT electrodes 1103, 1104, 1105, and 1106, the same tendency as that observed with respect to the first IDT electrode 1102 is recognized.

Since the pitch P_1 of the electrode fingers of the first IDT electrode 1102, the pitch P_2 of the electrode fingers of each of the second and third IDT electrodes 1103 and 1104, and the pitch P_3 of the electrode fingers of each of the fourth and fifth IDT electrodes 1105 and 1106 are in the relationship $P_1 > P_2 > P_3$, the center frequencies of radiation characteristics of the first, second, third, fourth, and fifth IDT electrodes 1102, 1103, 1104, 1105, and 1106 can be set approximately equal to each other.

That is, if the center frequencies of the radiation characteristics of the first, second, third, fourth, and fifth IDT electrodes 1102, 1103, 1104, 1105, and 1106 are equal to

each other, the surface acoustic wave filter of this embodiment has an attenuation characteristic of a wider band.

The surface acoustic wave filter is thus arranged to be realized as a wide-band filter having a steep attenuation characteristic.

While this embodiment has been described by assuming that the input terminal IN is of an unbalanced type, the input terminal IN is not limited to the unbalanced type. A balanced type of input terminal IN may alternatively be used.

While this embodiment has been described by assuming that the output terminal OUT is an unbalanced type, the output terminal OUT is not limited to the unbalanced type. A balanced type of output terminal OUT may alternatively be used.

The relationship between the numbers of electrode fingers of the first to fifth IDT electrodes is not limited to that described above. The relationship is optimized according to filter characteristics.

This embodiment has been described with respect to the case where the second and third IDT electrodes 1103 and 1104 is connected to the output terminal OUT while the first, fourth, and fifth IDT electrodes 1102, 1105, and 1106 is connected to the input terminal IN. However, the arrangement may alternatively be such that the second and third IDT electrodes 1103 and 1104 is connected to the input terminal IN while the

first, fourth, and fifth IDT electrodes 1102, 1105, and 1106 is connected to the output terminal OUT.

This embodiment has been described with respect to the case where the pitch of the electrode fingers of each IDT electrodes is adjusted and the case where the electrode finger pitch and the metalization ratio of each IDT electrodes are adjusted. However, the present invention is not limited to the described adjustment methods. The center frequencies of the radiation characteristics of the IDT electrodes can be set approximately equal to each other in a different manner as described below.

It is known that the peak frequency of the radiation characteristic of each IDT electrodes becomes lower if the film thickness of the IDT electrodes is increased. Therefore it is possible to adjust the peak frequencies of the radiation characteristics of the IDT electrodes to the desired frequency by setting the film thickness of the first IDT electrode and the film thickness of the second and third IDT electrodes to different values.

It is also known that the peak frequency of the radiation characteristic of each IDT electrodes is changed if the material of the IDT electrodes is changed. Therefore it is possible to adjust the peak frequencies of the radiation characteristics of the IDT electrodes to the desired frequency

by using different materials for the first IDT electrode and the second and third IDT electrodes.

It is also known that the peak frequency of the radiation characteristic of each IDT electrodes becomes lower if the metalization ratio of the IDT electrodes is increased.

Therefore it is possible to adjust the peak frequencies of the radiation characteristics of the IDT electrodes to the desired frequency by setting the metalization ratio of the first IDT electrode and the metalization of the second and third IDT electrodes to different values.

It is also possible to adjust the center frequencies of the radiation characteristics of the IDT electrode to the desired frequency by freely combining the above-described methods.

Each of the first to fourth embodiments has been described by assuming that the second and third IDT electrodes have numbers of electrode fingers equal to each other. However, the present invention is not limited to this arrangement. Even in a case where the second and third IDT electrodes have different numbers of electrode fingers, the same effect as that of the first to fourth embodiments can also be achieved if the electrode finger pitches are adjusted so that the peak frequencies of the radiation characteristics are equal to each other.

A communication device using the surface acoustic wave filter of the present invention in a portion of a transmitting circuit or receiving circuit also belongs to the present invention. Examples of such a communication device are a portable telephone terminal, a base station for portable telephone terminals, a motor vehicle telephone terminal, a terminal in a Personal Handyphone System, and a radar device.

A method of manufacturing a surface acoustic wave filter having a piezoelectric substrate, IDT electrodes for input, arranged on the piezoelectric substrate, and IDT electrodes for output, arranged on the piezoelectric substrate, in which the peak frequency of the radiation characteristic of the input IDT electrodes and the peak frequency of the radiation characteristic of the output IDT electrodes are set substantially equal to each other also belongs to the present invention.

A method of manufacturing a surface acoustic wave filter having a piezoelectric substrate, IDT electrodes for input, arranged on the piezoelectric substrate, and IDT electrodes for output, arranged on the piezoelectric substrate, in which the pitch of the electrode fingers of the input IDT electrodes and the pitch of the electrode fingers of the output IDT electrodes are set different from each other also belongs to the present invention.

The output IDT electrodes of the present invention are not limited to the first IDT electrode of the surface acoustic wave filter in the embodiment described above with reference to Figure 1 or 6, or to the fourth, fifth, and sixth IDT electrodes of the surface acoustic wave filter described above with reference to Figure 3 or 7. Also, the input IDT electrodes of the present invention are not limited to the second and third IDT electrodes of the surface acoustic wave filter in the embodiment described above with reference to Figure 1 or 6, or to the first, second, and third IDT electrodes of the surface acoustic wave filter described above with reference to Figure 3 or 7.

The embodiments of the present invention have been described with respect to the arrangement in which three IDT electrodes are formed as input and output IDT electrodes, and the arrangement in which five IDT electrodes are formed as input and output IDT electrodes. However, the present invention is not limited to these arrangements. Two IDT electrodes, four IDT electrodes or seven or more IDT electrodes may be formed as input and output IDT electrodes.

This embodiment has been described by assuming that the number of electrode fingers of the second IDT electrodes and that of the third IDT electrode are equal to each other, and that the number of electrode fingers of the fourth IDT electrode and that of the fifth IDT electrodes are equal to each other.

However, if these numbers are different, the IDT electrodes may be adjusted so that their radiation characteristics coincide with each other.

As is apparent from the foregoing, the present invention makes it possible to provide a surface acoustic wave filter of a wider band having a steep out-of-band attenuation characteristic, a method of manufacturing the surface acoustic wave filter, and a communication device using the surface acoustic wave filter.